

Micro-optical Modules for Board and Chip Level interconnects

C. Debaes, M. Vervaeke, Y. Isshii, B. Volckaerts, J. Van Erps, L. Desmet, H. Ottevaere, P. Vynck , V. Gomez, A. Hermanne, H. Thienpont

Lab for Applied Physics and Photonics

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Optical Interconnect Lenghts



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Bhanu Jaiswal University at Buffalo



Past and present European projects

Large European Consortia on Optical Interconnect Demonstrators





Past and present European projects

- European consortia have demonstrated highly advanced demonstrators
- Optical interconnect technologies are maturing:
 - Optoelectronic device technology
 - low threshold VCSEL, modulators, efficient detectors
 - Hybridization techniques
 - Many alternative waveguide fabrication technologies

We believe that one of the largest remaining challenges is to develop **Optical Interconnect Modules** that efficiently couple and reliably package with optoelectronic chips



Microfabrication of reliable components in polymers





Network of Excellence of Micro-Optics (NEMO)







Low-Cost Replication



Assembly, Integration and Packaging





Reliability



Measurement and Instrumentation



Modelling and Design



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NEMO Workpackage 9: Optical Interconnects



Ghent University (TFCG)

Vrije Universiteit Brussel (TONA)

VTT

Laser Ablation



Deep Proton Writing, DPW



Packaging and integration



CNRS-TSI

Solgel waveguides And grating couplers



F7K

Herriot Watt Univeristy

Direct Laser Writing





Microfabrication of reliable components in polymers



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Pluggable out-of-plane coupler for multimode waveguides

➔ 90° out-of-plane optical deflection important for use in optical paths between waveguides and optoelectronic devices (LDs, PDs)

➔ Mostly realised by using 45° micro-mirrors





The realized out-of-plane coupler

 <u>Deep Proton Writing</u> allows us to make versatile, pluggable components with very high quality 45° micro-mirrors



UltraAlign: XYZ + tip/tilt Hexapod: 6 DOF, 300nm repeatability Source: MMF, λ=850nm Detector: MMF Ø50μm core NA 0.22

Increases to **56.5% (-2.49dB)** when using index matching gel at the entrance facet of the out-of-plane coupling component



Microfabrication of reliable components in polymers





Large low-loss 2D fiber connectors



Fiber connector system for inter-chip interconnects



Multimode 6x4 fiber connector by integration of micro-milled structures and micro-holes fabricated with Deep Proton Writing



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Microfabrication of low-cost components in polymers





Intra-MCM interconnection modules



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OIIC: First Demonstration of intra-chip Optical links

Micro-optical Module Featuring:

- a micro-prism (500 µm thick)

- a baseplate with 2 times 2x8 micro-lens arrays

Manual Alignment with precision stages

Opto-electronic FPGA (OE-FPGA), Featuring:

- CMOS chip, non-aggressive 0.6µm technology

- flipchipped 2D VCSEL array, emitting at 980nm

- flipchipped 2D photodetector array (Fabricated in the framework of the OIIC-project) 4 Channel intrachip links Crosstalk -22dB 10Mb/s



C. Debaes, et all, "Low-cost micro-optical modules for MCM level optical Interconnections", IEEE J. of Sel. Topics in Quantum Electronics, Vol 9, No. 2, pp. 518- 530, 2003



Towards demonstration of a manufacturable DPW OI scheme

Main objectives of the demonstrator

- High-density intra-chip interconnects
 - Small channel pitches: from 220 μm down to 55 μm
 - Large channel density:

64x64 interleaved VCSEL/RCPD Array on 55 µm pitch matrix addressable

- Plug-and-play principle of optical pathway block
- Experimental verification of design rules
- Off-chip coupling
 - For inter-chip applications
 - For LAN applications
- Testbed for reconfigurable interconnects
- Testbed for aspherical optics
- First complete DPW integration with FSOI's

ESTEC Round Table Meeting 7/02/2006 | pag. 18 K.M. Geib, K.D. Choquette, D.K. Serkland, A.A. Allerman, T.W. Hargett, "Fabrication and performance of large (64x64) arrays of integrated VCSELs and detectors", SPIE Photonics West, 4649, 2002.





System Concept and tools



• Microspheres fit into precise microholes

Written in oneDPW process step





Obtained Tolerances with the Deep Proton Writing





Packaging: Low Temperature Co-fired Ceramic

- Wire carrier
 - Low Temperature Co-fired Ceramic wire carrier (130 µm thickness) bonded onto DPW alignment structure
 - Provides the clearance needed for the optical components
 - Eases bonding of small pitch device
- Adhesive bonding of spacer and chip
 - Using standard silver epoxy/UV-curable adhesive
 - Handling and flatness control is important
- Bonding
 - 62.5 µm gold wires
 - Chippad to wire carrier in short loops
 - Wire carrier to package pads are standard



Collaboration with VTT Elektroniikka (Oulu, Fin.)



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Conclusion





• In recent years, many European partners have developed and demonstrated innovative optical interconnects technologies

• Largest remaining challenges are related to building efficient interconnection modules and packages

• The NEMO network is working towards viable micro-optical solutions

Guide Pins



Strategic research with Future Valorisation Potential: Reconfigurable Optical Interconnects

Architectural Simulator



Identified Traffic Patterns



Target System

SunFire, 16 processors connected through a torus network and extra reconfigurable links



System Simulations

Measured performance increase ranging from 1%-40% depending on

- Benchmark application
- Reconfiguration interval
- Fanout and number of extra links



Practical Implementation

WDM inspired systems with wavelength **tunable VCSELS** and micro-optical elements



